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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: YOUNG-HOON PARK
SERIAL NUMBER: 09/848,577
FILED: May 3, 2001
FOR: REACTOR FOR DEPOSITING
THIN FILM ON WAFER

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) Group Art Unit:
) 1763
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) Examiner:
) Moore, Karla A.

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Commissioner for Patents
Washington, DC 20231

AMENDMENT

In response to the Office Action mailed on February 21, 2003, Applicant requests reconsideration in view of the following amendments and remarks.

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I HEREBY CERTIFY THAT THIS CORRESPONDENCE
IS BEING DEPOSITED WITH THE UNITED STATES
POSTAL SERVICE AS FIRST CLASS MAIL IN AN
ENVELOPE ADDRESSED TO:
ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D. C. 20231
ON April 21, 2003
DATE OF DEPOSIT
Jennifer Matson
(TYPED OR PRINTED NAME OF PERSON MAILING PAPER OR FEE)
[Signature] 4/21/03
SIGNATURE DATE